

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Akira Nakano et al.

Appln. No.: 10/043,739

Filed: January 9, 2002

For: Plasma Processing Apparatus
And System, Performance
Validation System And
Inspection Method Therefor

Attorney Docket No: 9281-4241

Examiner: MaGee, Christopher

Art Unit: 2653

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(i), Applicants hereby cite the following reference(s):

No.	Date of Publication
2000-182341	06/2000
2000-348451	12/2000
7-285219	10/1995
8-45994	02/1996
6-52145	07/1994
58-138043	08/1983
11-67806	03/1999
2000-286304	10/2000
9-223721	08/1997
2000-223513	08/2000
11-330125	11/1999
2000-357377	12/2000
WO 99/06993	02/1999

For the Examiner's convenience, Applicants are enclosing Form PTO-1449 (one sheet), along with a copy of each listed reference for which a copy is required under 37 C.F.R. §1.98(a)(2). Applicants respectfully request that the citation(s) be placed into the file wrapper of the application. Also enclosed is a copy of a Japanese Office Action that issued on July 14, 2004 for Japanese Patent Application No. 2001-003882.

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Attorney Docket No. 9281-4241

By submitting this Statement, Applicants are attempting to fully comply with the duty of candor and good faith mandated by 37 C.F.R. §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 C.F.R. §1.56(a).

Applicants have calculated no fee to be due in connection with the filing of this Statement. However, the Director is authorized to charge any fee deficiency associated with the filing of this Statement to a deposit account, as authorized in the Transmittal accompanying this Statement.

Respectfully submitted,

Date

9/22/04


Gustavo Siller, Jr. (Reg. No. 32,305)

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)		SERIAL NO. 10/043,739	CASE NO. 9281-4241
		FILING DATE 1/9/2002	GROUP ART UNIT 2653
		APPLICANTS: Masayoshi Nakagawa et al.	

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS			
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES	NO
B1	2000-182341	06/2000	Japan		X	
B2	2000-348451	12/2000	Japan		X	
B3	7-285219	10/1995	Japan		X	
B4	8-45994	02/1996	Japan		X	
B5	6-52145	07/1994	Japan		X	
B6	58-138043	08/1983	Japan		X (Claim)	
B7	11-67806	03/1999	Japan		X	
B8	2000-286304	10/2000	Japan		X	
B9	9-223721	08/1997	Japan		X	
B10	2000-223513	08/2000	Japan		X	
B11	11-330125	11/1999	Japan		X	
B12	2000-357377	12/2000	Japan		X	
B13	WO 99/06993	02/1999	PCT		X	

EXAMINER INITIAL	OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)	
B14	Japanese Office Action dated July 14, 2004 for Japanese Patent Application No. 2001-003882	

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.